TECHNOLOGY CENTER R3700

Confirmation No. 4320

Norio KIMURA et al. Docket No. 2001 0122A

Serial No. 09/777,707 Group Art Unit 3723

Filed February 7, 2001 Examiner Willie W. Berry, Jr.

**POLISHING APPARATUS** 

**AMENDMENT** 

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT **ACCOUNT NO. 23-0975** 

Assistant Commissioner for Patents, Washington, D.C.

Sir:

In Response to the Office Action dated December 7, 2001, please amend the above-identified application as follows:

## In The Specification:

Please amend the specification as follows.

Please replace the paragraph beginning at page 4, line 21, with the following rewritten paragraph.

By preliminarily supplying a pressurized fluid to the above-mentioned cylinder so as to counter the weight of the dresser, the pressure between the dresser tool and the polishing surface of the turntable can be easily minimized to a level less than the weight of the dresser and adjusted to an arbitrary value exceeding that level (for example, a value in a range of 10 N to 300 N).

Please replace the paragraph beginning at page 7, line 21, with the following rewritten paragraph.

The air cylinder 9 is a low-friction type and the kinetic frictional resistance generated when a piston in the air cylinder 9 is moved is about 0.44 kg or less. Air is supplied through the controller